

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S79	2018	347/68.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/15 16:26
S80	2018	S79	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/15 17:23
S81	661	347/70.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/15 16:26
S82	661	S81	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/15 16:55
S83	783	347/71.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/15 16:26
S84	783	S83	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/15 16:30
S85	261	347/72.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/15 16:26
S86	261	S85	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/15 16:31

EAST Search History

S87	631	347/50.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/15 16:55
S88	2	S80 and first near (land (contact near pad)) same second near (land (contact near pad)) same piezoelectric near (element device actuator body structure)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/15 17:25
S89	20	first near (land (contact near pad)) same second near (land (contact near pad)) same piezoelectric near (element device actuator body structure)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/15 17:25

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	2	piezoelectric near (element device structure) same first near (land (contact near pad)) same second near (land (contact near pad)) same (electrode conductor)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/19 08:59
L2	3381	347/68-72.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/19 08:59
L3	2	L2 and piezoelectric near (element device structure) same first near (land (contact near pad)) same second near (land (contact near pad)) same (electrode conductor). clm.	US-PGPUB	OR	ON	2007/03/19 09:00
L4	631	347/50.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/19 09:00
L5	1	L4 and piezoelectric near (element device structure) same first near (land (contact near pad)) same second near (land (contact near pad)) same (electrode conductor). clm.	US-PGPUB	OR	ON	2007/03/19 09:00
L6	2	"347"/\$.ccls. and piezoelectric near (element device structure) same first near (land (contact near pad)) same second near (land (contact near pad)) same (electrode conductor).clm.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/19 09:02